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**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE –
EXAMINING GROUP 1763**

TOWNSEND and TOWNSEND and CREW LLP

By: /Nina L. McNeill/
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PATENT
Attorney Docket No.: AM2119/T21300
AMAT No.: AM2119/T21300
TTC No.: 16301M-021300US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Karl Littau et al.

Application No.: 08/893,917

Filed: July 11, 1997

For: REMOTE PLASMA CLEANING
SOURCE HAVING REDUCED
REACTIVITY WITH A SUBSTRATE
PROCESSING CHAMBER

Customer No.: 57385

Confirmation No. 8435

Examiner: Rudy Zervigon

Technology Center/Art Unit: 1763

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE EXAMINING
GROUP 1763**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed January 29, 2007 on the above-referenced application, please enter the following amendments and remarks:

A **Listing of Claims** begins on page 2 of this paper.

Remarks begin on page 6 of this paper.